Plasmonic Surface Nanostructuring of Au-dots@SiO$_2$ via Laser-Irradiation Induced Dewetting

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Abstract

The in-situ observation of Au dot formation and the self-assembly dynamics of Au nanoparticles (NPs) was successfully demonstrated via dewetting of Au thin films on SiO$_2$ glass substrates under nano-second pulsed laser irradiation using a multi-quantum beam high-voltage electron microscope. Moreover, using electron energy-loss spectroscopy (EELS) performed in a scanning transmission electron microscope (STEM), the plasmonic properties of the formed Au/SiO$_2$ nanostructure were analyzed to demonstrate its validity in advanced optical devices. The uniformly distributed Au NPs evolved into a dot alignment through movement and coalescence processes was demonstrated in this in-situ observation. We carried out the Plasmon-loss images of the plan view and the cross-section of the Au/SiO$_2$ nanostructures were obtained at the plasmon-loss peak energy for investigate the three-dimensional distribution of surface plasmon. Furthermore, discrete-dipole approximation (DDA) calculations were used to simulate the plasmonic properties, such as the surface plasmon resonance and the surface plasmon field distribution, of isolated single Au/SiO$_2$ nanostructures. This STEM-EELS-acquired surface plasmon map of the cross-sectional sample is in excellent agreement with the DDA
calculations. This results demonstrated the influence of the contact condition between Au NP and SiO₂ glass on the plasmonic properties, and may improve the technology for developing advanced optical devices.
1. Introduction

The direction and periodic intervals of femtosecond- or nanosecond-pulsed laser-induced periodic surface structures (LIPSS) strongly depend on the wavelength and electric field vector ($E$ vector) of the incident laser [1, 2]. Recently, we successfully obtained LIPSS via nanosecond-pulsed laser irradiation and via Ar$^+$ ion and nanosecond-pulsed laser co-irradiation on an Au thin film deposited on SiO$_2$ glass substrates [3, 4]. Also, the obtained direction of the LIPSS was either parallel [1, 3] or perpendicular [2, 4] to the $E$ vector of the incident laser.

Recently, transmission electron microscope (TEM) in situ observations of thermal annealing-induced [5] or pulsed laser-induced [6, 7] dewetting of metallic films deposited on a dielectric substrate was obtained during the assembly process of the metallic films into a nanoparticle (NP) array. These results have demonstrated that in situ observation using a modified TEM is an effective method to study the thermal annealing- or quantum beam irradiation-induced dewetting. However, in situ observational research capturing the NP array variation as a function of increased laser pulse is as yet insufficient. In previous works, we have reported in situ observation of nanosecond-pulsed irradiation-induced dewetting evolution of an Au film on an SiC substrate using a high-voltage electron microscope (HVEM) equipped with a nanosecond-pulsed laser [8].

Noble metallic NPs exhibit the well-known quantum phenomena of surface plasmon resonance (SPR), which is a collective oscillation of conduction electrons driven by the incident light. The SPR can enhance the electronic field surrounding the noble metallic NPs, which is capable of enhancing the performance of biosensors [9], photocatalysts [10-12] and solar cells [13, 14]. The desired SPR frequency of a noble metallic NP/dielectric system can be produced by controlling the size [15, 16], shape [16] and interparticle distance [17] of the noble metallic NPs. Therefore, clarifying the
mechanism underlying the noble metallic NP formation can be the key to controlling the morphology and distribution of the noble metallic NPs, and ultimately to tailoring the SPR properties.

We have previously investigated the photoabsorption spectrum of the formed noble metallic NP/dielectric systems to analyze the plasmonic properties of the SPR induced by the incident light [3, 4, 18-21]. Additionally, we have used discrete-dipole approximation (DDA) calculations to understand the incident light-induced optical properties and the surface plasmon distribution of the Au NP/SiO₂ nanostructures [21]. In these results, generally the wavelengths of the SPR peak red shifts are in good agreement with the increase in the mean diameter of the Au NPs on the SiO₂ substrates [3, 4, 18-21]. However, the formation of LIPSS as a result of co-irradiation with Ar⁺ ions and a nanosecond-pulsed laser leads to unexpected SPR peak blue shifts as the mean diameter of the Au NPs on the SiO₂ substrates increases [4]. This unexpected SPR peak blue shift is possibly owing to the effects of the charge distribution around the Au NPs resulting from the relative differences in the distances between the Au NPs formed by LIPSS [4, 17]. However, it is difficult to obtain the surface plasmon distribution around the Au NPs using photoabsorption spectroscopy. Electron energy-loss spectroscopy (EELS) performed in a scanning TEM (STEM), however, enables mapping of the distribution of electrically excited surface plasmons of metallic nanostructures [22-26]. The surface plasmon modes and distribution can be influenced by changes in the shape [22-24], size [26] and interparticle distance [25] of the metallic nanostructures. The results of the STEM-EELS experiment were in excellent agreement with theoretical calculations from methods such as the boundary element method [23-27]. Therefore, using STEM-EELS experiments and theoretical calculations it is possible to probe the unique plasmonic properties in periodic metallic NP/dielectric nanostructures.

In this study, the in-situ observation experiment successfully demonstrated the Au dot formation
and the self-assembly dynamics of Au nanoparticles (NPs) via nanosecond-pulsed laser irradiation-induced dewetting of Au thin films on an SiO$_2$ glass substrate using a multi-quantum beam HVEM (MQB-HVEM), which can be developed the control technology of laser induced dewetting. We successfully observed the initial process of LIPSS formation using a MQB-HVEM, and investigated the plasmonic properties of the formed Au/SiO$_2$ nanostructures via STEM-EELS. We carried out the plasmon-loss images of the plan view and the cross-section of the Au/SiO$_2$ nanostructures were performed at the plasmon-loss peak for investigating the three-dimensional distribution of surface plasmon. Moreover, we compared the results for the plasmonic properties of the Au/SiO$_2$ nanostructures obtained from both DDA calculations and STEM-EELS experiments. The above results demonstrated the formed Au/SiO$_2$ nanostructures validity in advanced optical devices, and may improve the technology for developing advanced optical devices.

2. Experimental procedure

The SiO$_2$ glass substrates with a diameter of 10 mm and a mirror finish on both sides (Shin-Etsu Chemical Co., Ltd., Tokyo, Japan, O-H density: 501 ppm, dielectric constant: 3.9) were used in ex situ irradiation experiments. The in situ samples were cut from the same SiO$_2$ glass substrates used for the ex situ samples, where the cut pieces were mechanical thinned from the back surface up to a thickness of 0.03 mm. The TEM samples were prepared by Ar$^+$ ion polishing from the back surface at an angle of 5 degrees using a precision ion polishing system (PIPS; Gatan Co., Ltd., CA, USA). The Au thin films were simultaneously deposited on the ex situ and in situ samples (mirror surface) using a vacuum evaporator at room temperature by electrically heating the Au source (purity, 99.9%) operated at a pressure of 7.0×10$^{-3}$ Pa.
In this study, the in situ irradiation experiments were performed in a MQB-HVEM (JEOL, JEM-ARM1300, Tokyo, Japan) equipped with a nanosecond-pulsed laser (Inlite II, Continuum Co., Ltd., CA, USA). The nanosecond-pulsed laser operated at a wavelength of 532 nm with a nominal pulse duration of 5–7 ns and a repetition rate of 2 Hz. The nanosecond-pulsed laser was irradiated onto the surface of the Au thin film on the SiO$_2$ glass substrate at an angle of 44 degrees. A video of the laser-induced dewetting was recorded using the bottom-mounted charge-coupled device (CCD) camera of the MQB-HVEM at a frame rate of 10 frames per second (HD video software: Gatan DigitalMicrograph, Ver. 2.30.542.0, video formats: *.mpeg4). Because this in situ experimental apparatus does not have a synchronized system between the sequential CCD frames and the laser pulses, we determined that a frame exhibiting a microstructure change when compared to a previous frame was obtained just after a laser strike. We also confirmed that every five frames after this initial laser strike frame exhibited some change in the microstructure caused by the laser irradiation. Further, the ex situ irradiation experiments and nanosecond-pulsed laser energy density measurements were performed using an ex situ experimental apparatus, wherein the laser was irradiated perpendicular to the surface of the Au thin film on the SiO$_2$ glass substrate. The average laser energy density was 50 mJ/cm$^2$.

After the ex situ irradiation, photoabsorbance measurements were performed with a spectrophotometer (JASCO, V-630, Tokyo, Japan) using an aperture with a diameter of 0.1 mm to confine the irradiated region. The surface morphology of the samples was observed by SEM (JEOL, JSM-7001FA, Tokyo, Japan), and cross-sectional microstructural analyses were performed via TEM (FX-TEM; JEOL, JEM-2000FX). The EELS analyses were performed via a spherical aberration-corrected STEM (Cs-STEM; FEI, Titan G2 60-300) equipped with an electron monochromator, which
improves the electron energy resolution to about 0.12 eV (defined by the full width at half maxima of the zero-loss peak). To analyze the peak occurring in the EELS spectrum, we using the Gaussian non-linear least squares (NLLS) fitting, Zero-loss peak removal and background removal via the DigitalMicrograph (Ver. 2.11.1404.0) software. Cross-sectional TEM samples for the FX-TEM and the spherical aberration-corrected TEM/STEM (Cs-TEM/STEM; FEI, Tital G2 60-300) were prepared using focused ion beam equipment (FIB; JEOL, JEM-9320).

In this study, the DDA method was applied to calculate the photoabsorption coefficients and the surface plasmon near-field distribution of the Au NPs on the SiO$_2$ glass substrate, using the software package DDSCAT 7.3 developed by Draine and Rlatau [28, 29]. In addition, the Meng et al. [21] modified model of an Au NP on a hemispherical SiO$_2$ glass substrate was used for the DDA calculation in this work. The wavelength-dependent dielectric function of bulk Au extracted from Johnson et al. [30] was used, as was the dielectric constant (3.9) of the SiO$_2$ glass substrate. After the DDA calculation, a schematic illustration of the 3D model of the Au NP on the surface of the SiO$_2$ glass substrate was obtained by Paraview 4.4.0 [31].

3. Results and Discussion

Figure 1(a) shows an SEM image of the surface morphology of the ex situ sample, where the surface can be seen to exhibit an uneven covering of Au granular grains on the as-deposited Au thin films on the SiO$_2$ glass substrate. The cross-sectional sample was prepared from the as-deposited ex situ sample using FIB equipment, and from the cross-sectional FX-TEM image (Figure 1(b)), the thickness of the Au thin films are seen to be approximately 15 nm thick. In these FX-TEM observations, the areas that appear thinner than the other regions may be the crack-like structures seen
in Figure 1(a). Figure 1(c) shows an FX-TEM image of the surface morphology and a selected area diffraction pattern of the in situ sample, where the same Au granular grains can be observed on the surface of the as-deposited Au thin films on the SiO$_2$ glass substrate of the in situ sample as seen on the ex situ sample. The selected area diffraction pattern confirms the as-deposited Au thin films to be polycrystalline. Therefore, the Au thin film is considered to be uniform and with a thickness of approximately 15 nm.

First, we carried out ex situ irradiation experiments to investigate the optical properties by visible optical absorption spectra. Figure 1(d) and (e) show a surface morphology SEM image and a cross-sectional Cs-TEM image, respectively, of the irradiated ex situ sample obtained after 10 pulses. After 10 pulses of irradiation, the aspect ratio of the diameter/height of the formed Au NP is about 1.18, and the contact angle between the Au NP and the SiO$_2$ glass substrate is $\theta_1=143.8^\circ$. This contact angle is consistent with the classical contact angle between a liquid Au NP and an SiO$_2$ glass substrate [32]. Figure 1(f) shows the visible optical absorption spectrum of the irradiated ex situ sample after 10 pulses, exhibiting a clear peak corresponding to an SPR-enhanced absorption at a wavelength of 537 nm (photon energy: 2.31 eV). These results demonstrate that, after laser irradiation with an average energy density of 50 mJ/cm$^2$ for 10 pulses, Au NPs are formed on the surface of SiO$_2$ glass substrate that demonstrate some SPR effect. Therefore, these laser parameters were used to perform the in situ observation experiment.
Generally, dewetting on the surface of a dielectric substrate is accomplished by a process wherein, first, hole formation occurs in the metallic thin films; second, hole growth progresses; third, ligament breakup occurs; and finally, metallic NPs are formed \([6, 33]\). Yang et al. have made very well ordered surface nanopatterns of Au and Ag NPs by using temple-confined dewetting process \([34]\). McKeown et al. have observed the progression of a metallic film into an NP array by in situ nanosecond-pulsed laser irradiation \([6, 7]\). Further, increasing the number of laser pulses can induce the arrangement of the Au NPs to change and the formation of LIPSS to occur at suitable conditions \([3, 4]\). As shown in Figure 1(d), several Au NPs in the yellow box are in a line-like arrangement. Figure 2 show the dewetting process of the in situ sample during the in situ nanosecond-pulsed laser irradiation experiment with a varying number of laser pulses, where the images are obtained from the
video test by MQB-HVEM (The video of the in situ observation running from before irradiation until 600 irradiation pulses is available in the Supplementary Information, Video M1). Immediately after the initial irradiation pulse, the Au thin films change to Au NPs possessing diameters from a few tens to a few hundreds of nanometers (Figure 2(b)). After two irradiation pulses, some of the Au NPs vanish from the view of the in situ observation, which we hereafter call the “vanished Au NPs.” In addition to the occurrence of vanished Au NPs, movement, coalescence and growth of the remaining Au NPs were observed. In this in situ observation experiment, after 600 irradiation pulses the size, shape and distribution of the Au NPs are likely to stabilize. Therefore, we analyzed the behavior of the movement, coalescence and distribution of the Au NPs as a function of irradiation up to 600 irradiation pulses. As shown in Figure 2, the behavior of the Au NPs is analyzed using the in situ MQB-HVEM images, analyzing consecutive images for Au NPs movement (blue arrows), coalescence and growth (red arrows), and vanished Au NPs (orange dotted circle) as the number of laser pulses is increased. (The comparison of different MQB-HVEM images obtained after different numbers of laser pulses, the image processing method and the results are displayed in Supporting Information S1.) In this in situ observation experiment, the vanished Au NPs often occur in the area enclosed by yellow dotted lines in Figure 2. These vanished Au NPs may disappear owing to laser ablation, and based on these results, we consider this area to be one that experiences a high laser energy. In this high-laser-energy area, the number of Au NPs decreases because several Au NPs vanish or move to both sides (yellow dotted line in Figure 2), where the Au NPs ultimately develop into a line-like arrangement (analysis method displayed in Supporting Information S2).

The evolution of the size and shape of the Au NPs was also analyzed as a function of increasing number of laser pulses using the TEM images of the in situ observation. Figure 3(a) plots the average
Figure 2. In situ observation of nanosecond-pulsed laser irradiation-induced dewetting of the in situ sample obtained (a) before irradiation and obtained after laser irradiation for (b) 1, (c) 2, (d) 3, (e) 4, (f) 50, (g) 100, (h) 300 and (i) 600 pulses. Each still image was extracted from the video of the in situ observation recorded by CCD camera (video formats: *.mpeg4). Marks indicate Au NPs that have moved (blue arrows), coalesced and grown (red arrows), and vanished (orange dotted circle) with increased number of laser pulses.
Heywood diameter and average aspect ratio of the Au NPs with respect to the number of laser pulses. After 1 irradiation pulse, the average Heywood diameter of formed Au NPs is 60.1±1.2 nm. In this study, as the number of pulses increases from 1 to 10, the average Heywood diameter increases and simultaneously the average aspect ratio suddenly decreases. After 10 irradiation pulses, the average Heywood diameter is maximized (65.9±1.5 nm) for this in situ observation experiment. As the number increases from 10 to 600 irradiation pulses, the average Heywood diameter decreases to 60.4±1.2 nm while the aspect ratio, which initially exhibits a slight fluctuation, ultimately stabilizes at a value of 1.2 in this in situ observation experiment. The average Heywood diameter of Au NPs after 1 and 600 irradiation pulses are close. However, the distribution of the average Heywood diameter of Au NPs are different between them. As increasing laser irradiation pulses, the histogram is getting to show Gaussian distribution and highest frequency of Heywood diameter of Au NPs is going toward into the average value.

Figure 3(c) shows the extended MQB-HVEM image obtained from an area marked by a red square in Figure 2(i). Because of the higher point–point resolution in the MQB-HVEM image than is available in the video of the in situ observation, many small Au NPs are observed herein than was possible in the video. The Heywood diameter histogram of the small Au NPs is show in Figure 3(d), exhibiting an average of 6.5±0.1 nm. Therefore, the movement process of the larger Au NPs could be achieved through coalescence around these small Au NPs.

Generally, LIPSS are formed as a result of the interference between the incident laser light and the scattered laser light induced by defects or unevenness of the substrate surface [1-4]. Longstreth-Spoor et al. [35] have investigated the periodic surface nanostructures of Co on Si substrates by two-beam
Figure 3. (a) Average Heywood diameter (equivalent circle diameter) and average aspect ratios of the Au NPs as a function of the number of laser pulses. Error bars indicate the standard error. (b) Histogram of the Heywood diameters obtained from the in situ TEM image in Fig. 2(b). (c) High-magnification MQB-HVEM image obtained after the in situ observation of the area in the red square in Fig. 2(i). (d) Histogram of the Heywood diameters of these small Au NPs observed in Fig. 3(c).
laser interference irradiation, where small Co NPs formed in regions of constructive interference (high temperature regions) and large Co NPs formed in regions of destructive interference (low temperature regions) [35]. Recently, we examined nanosecond-pulsed laser irradiation [3] as well as Ar$^+$ ion and nanosecond-pulsed laser co-irradiation [4] upon Au thin films deposited on SiO$_2$ glass substrates. Therein, initially the Au NP formation was dispersed uniformly, and as the irradiation dose was increased, ultimately the LIPSS formed on the SiO$_2$ glass substrate. In that study, however, we inadequately explicated the process underlying the change of the uniformly dispersed Au NPs to LIPSS.

From the result of this study, we now reconsider the LIPSS formation process. Under single-beam laser irradiation and based on the interference between the incident laser light and the scattered laser light, the energy density was periodically distributed on substrate surface. In the regions of constructive interference, some of the Au NPs vanish by laser ablation while some move to regions of destructive interference. Therefore, on the surface of substrate, the number of Au NPs will decrease in regions of constructive interference and will increase in regions of destructive interference. Finally, randomly-dispersed Au NPs change to a periodic nanostructure.

From the results of the in situ observation, we record the dewetting behavior of Au thin films on SiO$_2$ glass substrates during nanosecond-pulsed laser irradiation and analyzed the change of the Heywood diameter and the aspect ratio. We also carried out STEM-EELS experiments to investigate the plasmonic properties of the formed Au NPs induced by laser irradiation.

Figure 4 shows the results of the STEM-EELS experiment on the in situ sample. Figure 4(a) shows a Cs-TEM image of the in situ sample surface after 600 irradiation pulses, and Figure 4(b) shows the EELS spectrum for an incident electron beam at a point near an Au NP on the in situ
Figure 4. (a) Cs-TEM image of the in situ sample obtained after 600 irradiation pulses. (b) Extracted experimental STEM-EELS spectrum for an incident electron beam at point 1 marked in (a). (c) Surface plasmon map obtained from the measured STEM-EELS excitation intensity at the area in the red square in (a) with an energy selection slit at 0.1 eV from 1.83 to 2.43 eV and a mesh dimension of 5×5 nm².
Figure 5. (a) Cross-sectional Cs-TEM image obtained after 7500 irradiation pulses for the sample described in Ref. 4. (b) Extracted experimental STEM-EELS spectrum for an incident electron beam at point 2 marked in (a). (c) Surface plasmon map obtained from the measured STEM-EELS excitation intensity at the area in the red square in (a) with an energy selection slit at 0.1 eV from 1.85 to 2.45 eV and a mesh dimension of 2×2 nm².
sample (labeled point 1 in Figure 4(a)). The EELS spectrum exhibits a clear peak corresponding to the plasmon loss peak (labeled peak 1 in Figure 4(b)). After Gaussian NLLS fitting of the peak via DigitalMicrograph, we obtained a plasmon loss energy of 2.18 eV. This plasmon loss energy is close to the reported plasmon loss peak of Au nanostructures obtained by Chu et al. [22-23].

Therefore, a surface plasmon map was obtained by mapping the STEM-EELS excitation intensity from an area including an Au NP (square area in Figure 4(a)) with an energy selection slit at 0.1 eV and ranging from 1.93 to 2.43 eV (Figure 4(c), mesh dimension of 5×5 nm²). As shown in Figure 4(c), the near-field distribution of the surface plasmons surrounding the Au NP is demonstrated.

In our previous study, we reported that the Au NPs formed on the SiO₂ glass substrate were induced by nanosecond-pulsed laser irradiation in the vacuum chamber [4]. Moreover, we demonstrated therein via cross-sectional TEM images that an Au NP formed on the surface of the SiO₂ glass substrate [4]. In this work, a cross-sectional Cs-TEM image of the same cross-sectional sample prepared for use in our previous study is shown in Figure 5(a). To investigate the cross-sectional plasmonic properties of the Au/SiO₂ nanostructures in this cross-sectional sample, we obtained surface plasmon maps by mapping the STEM-EELS excitation intensity. Figure 5(b) shows the EELS spectrum for an incident electron beam at a point near an Au NP on the cross-sectional sample (labeled point 2 in Figure 5(a), zero-loss peak and background of EELS spectrum was removed), where the EELS spectrum has a clear peak corresponding to a plasmon loss peak (labeled peak 2 in Figure 5(b)) whose energy, by Gaussian NLLS fitting, was found to be 2.20 eV. Therefore, the surface plasmon map was obtained by mapping the STEM-EELS excitation intensity from an area containing an Au NP and some SiO₂ substrate (square area in Figure 5(a)) with an energy selection slit at 0.1 eV and ranging from 1.85 to 2.45 eV (Figure 5(c), mesh dimension of 2×2 nm²). As shown in Figure 5(c),
the near-field distribution of the surface plasmons exists at the right and left outsides of the interface between the Au NP and the SiO$_2$ glass substrate. In particular, the maximum STEM-EELS excitation intensity is clearly present at the right outside of the interface between the Au NP and SiO$_2$ (Figure 5(c)). In previous works, we obtained Au NPs partially embedded in the SiO$_2$ glass substrate following Ar$^+$ ion irradiation [18-21] or nanosecond-pulsed laser and Ar$^+$ ion co-irradiation [4], where the embedded depth could be controlled by the Ar$^+$ ion dose. Therefore, the cross-sectional surface plasmon distribution of these partially embedded Au NPs with varying embedded depth could be probed by STEM-EELS in future work.

As shown in Figure 5(a), the aspect ratio of the diameter/height of the Au NP is about 1.22. Therefore, DDA calculations were run using this aspect ratio, and the 3D model is schematically illustrated in Figure 6 of a single Au NP on the surface of an SiO$_2$ glass substrate in the cross-sectional (X-Y plane) view (Figure 6(a)) and the top view (Y-Z plane) (Figure 6(b)). The contact between the Au NP and SiO$_2$ glass substrate was a surface contact (Figure 6(a)), and Figure 6(c) shows the DDA-calculated absorption coefficient plotted for wavelengths from 400 to 800 nm (wavelength spacing of 1 nm for 500–550 nm range, and 8 nm otherwise). In this DDA calculation, the incident light was along the X-direction and was polarized along the Y-direction. This calculated absorption coefficient plot exhibits a clear peak at a wavelength of 525 nm (photon energy: 2.36 eV), corresponding to an SPR-enhanced absorption. The simulated plasmon near-field distributions were then calculated at this SPR peak wavelength (Figure 6(d)), and the color bar shows the electric field enhancement $|E|^2/|E_0|^2$, where $|E_0|$ is the amplitude of the incident field and $|E|$ is the amplitude of the local electric field surrounding the Au/SiO$_2$ nanostructure. As shown in Figure 6(d), the surrounding environment of the Au NP exhibits a dipole-like plasmon field
distribution. In addition, regions with field enhancement up to 50 times or more exist at the outsides of the interface between the Au NP and the SiO$_2$ glass substrate. The region of most enhancement field exhibited at corners near the contacts of Au NP to the SiO$_2$ glass substrate is excellent agreement with the STEM-EELS-acquired surface plasmon map of the cross-sectional sample. (Figure 5(c)). However, the simulated plasmon field distribution of left and right sides is symmetrical, but the experimental cross-sectional plasmon field distribution of the left and right sides is significantly different (Figure 5(c)).

In this study, the STEM-EELS-acquired energy of the plasmon loss peak is significantly lower than the calculated photon energy of the SPR peak. A redshift (shift to the lower energy side) of the SPR peak can be driven by closely-coupled metallic NPs [36, 37]. As can be seen in Figure 3(c) and 4(a), following laser irradiation, a number of relatively small Au NPs a few nanometers in diameter are asymmetrically dispersed around the larger Au NP. The difference existed between the experimental and theoretical results in the case of the plan view STEM-EELS experiment may therefore be the result of these small Au NPs. In the case of cross-sectional experiment, the plasmon loss peak could be influenced by the tens of nanometers Au NP on its left side of the measured Au NP as shown in Figure 5(a). Take a closer look at the Figure 5(b), a shoulder peak was observed in the lower energy side of the main plasmon loss peak. For coupled Au nanostructures, it has been shown that STEM-EELS can reveal the different surface plasmon distribution depending on the different surface plasmon modes [23-25]. Also, the STEM-EELS can reveal the different plasmon loss peaks
depending on the different surface plasmon modes, and a shoulder peak can be existed when the
energy of two peak are close [23-25]. Therefore, the shoulder peak as shown in Figure 5(b) could be
exhibits two surface plasmon modes induced by interaction between coupled two Au NPs as show in
Figure 5(a). Clarification of the shoulder peak will be an import aspect of future work. In addition,

![Diagram of Au NP on SiO2 substrate](image)

**Figure 6.** Schematic illustration of the 3D model used for the DDA simulation: (a) cross-
sectional (X-Y plane) and (b) top-view (Y-Z plane) configuration of a single Au nanoparticle on the SiO2 glass substrate surface. (c) DDA-calculated absorption coefficient plotted as a function of wavelength from 400 to 800 nm (wavelength spacing is 1 nm for 500–550 nm, and 8 nm otherwise). (d) Cross-sectional surface plasmon field distribution contours at the SPR peak wavelength obtained in (c). In this DDA calculation, the incident light is along the X-direction and is polarized along the Y-direction.
symmetrically patterned Au nanostructures exhibit a symmetric distribution pattern of the surface plasmon field [23, 24]. On the other hand, Meng et al. [21] have investigated the plasmon field distribution of Au NPs partially embedded in SiO$_2$ glass substrates at the SPR peak using the DDA calculation method, where their results showed that the maximum plasmon field enhancements exist at the junction regions between the Au NPs and the silica glass substrate. The plasmon field distribution of metallic NPs on the dielectric is strongly influenced by contact angle between metallic NPs and substrate [21, 38, 39]. The plasmon field is enhanced at corners near the contacts of Au NP to the SiO$_2$ glass substrate could be indicated the electron oscillation on the Au NPs near the contacts region [21, 38, 39]. From the above results, the plasmon field distribution of Au NP could be controlled by the distribution of the Au NPs and the contact situation between the Au NPs and the SiO$_2$ glass substrate.

Conclusions

In conclusion, using in situ observation experiments we have successfully and simultaneously observed the formation of Au NPs and the modification of these Au NP shapes and arrays with increasing number of laser pulses via laser irradiation-induced dewetting of Au thin films on SiO$_2$ glass substrates. The first stage (from 1 to 10 irradiation pulses) was dominated by coalescence and growth, wherein the Heywood diameter of Au NPs increased. In the second stage (from 11 to 600 irradiation pulses), however, the Heywood diameter of Au NPs decreased. The Au NP arrays evolved as the number of laser irradiation pulses increased where, through movement and coalescence, some of the Au NP arrays evolved to exhibit alignment. The plasmonic properties of these Au/SiO$_2$ nanostructures formed by laser irradiation were measured using surface plasmon maps obtained via
STEM-EELS. Moreover, the plasmonic properties of the Au/SiO$_2$ nanostructures were obtained using both theoretical calculations and laser irradiation experiments, and the results were compared. Finally, the 3D surface plasmon distribution of them was obtained by using a combination of the plan view and the cross-sectional experiments. The results in this study can therefore facilitate understanding of the dynamics of the NP arrays induced by laser irradiation and reveal new technology that can be used to control the arrays and the plasmonic properties of Au NPs for future development of advanced optical devices.

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Author Contributions

The manuscript was written through contributions of all authors. All authors have given approval to
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References


Supporting Information

M1. The video of the laser-induced dewetting was recorded in situ observation running from before irradiation until 600 irradiation pulses using the bottom-mounted charge-coupled device (CCD) camera of the MQB-HVEM at a frame rate of 10 frames per second (HD video software: Gatan DigitalMicrograph, Ver. 2.30.542.0, image resolution: 974×974 pixels, video formats: *.mpeg4).

In this supporting information, the upload video M1 format is convert to *.mpg and the play speed is 64 times faster (Image resolution is convert to 360×360 pixels).

S1. The comparison of different MQB-HVEM images obtained after different numbers of laser pulses.

Image processing

First, each still image was extracted from the movie, where each still image had a resolution of 974×974 pixels with an 8-bit RGB (red-green-blue) color scale. Second, the 8-bit RGB color scale was converted to an 8-bit grayscale. Finally, each still image possessed a resolution of 690×690 pixels after cropping (hereafter referred to as the in situ MQB-HVEM image).

To detect morphological changes and track the individual Au NPs on the SiO$_2$ glass substrate, the grayscale in situ MQB-HVEM images were converted to exhibit only black for the Au NPs and white for the SiO$_2$ glass substrate images via a binarization method using Adobe Photoshop CS6. We applied a manual adjustment threshold value for the binarization of each MQB-HVEM image to detect the edge of the Au NPs that was optimized based on visual inspection.

In this in situ observation experiment, the size, shape and distribution of the Au NPs were likely to
be stabilized after 600 irradiation pulses, so we analyzed the movement, coalescence and distribution behavior of the irradiated Au NPs up to this number of pulses. To analyze the behavior, we compared image-processed MQB-HVEM images for a varying number of laser pulses (image processing method given in the experimental procedure). The image position alignment was accomplished using an Au NP present in all of the images that experienced almost no shape change during the in situ observation and that possessed a unique shape resembling the letter `F` (yellow frame in Figure S1(b)). Figure S1(b)–(i) show the TEM images obtained after 1, 2, 3, 4, 50, 100, 300 and 600 pulses, respectively. Figure S2(a)-(g) show the comparison images between an initial and final image, where the Au NPs appearing in the initial image are colored red and those in the final image are blue. The initial/final comparison images in Figure S2(a)-(g) respectively compare 1 pulse/2 pulses, 2 pulses/3 pulses, 3 pulses/4 pulses, 4 pulses/50 pulses, 50 pulses/100 pulses, 100 pulses/300 pulses and 300 pulses/600 pulses. Therefore, in the comparison image, blue Au NPs are those that appear after laser irradiation, the red Au NPs are those that have dispersed after laser irradiation, and the red and blue combined (i.e., purple) regions indicates Au NPs that have not changed. In addition, the movement of the Au NPs is indicated by black arrows, while coalesced Au NPs are indicated by green arrows. From 1 to 4 irradiation pulses, some of the Au NPs are seen to have moved to the line-like arrangement of NPs (black dotted line in Figure S2(a)-(g)) and are combined with Au NPs in the neighborhood of the line-like arrangement. Therefore, the number of Au NPs is reduced by the nanosecond-pulsed laser irradiation in the region between the black dotted lines. As shown in Figure 2 in the manuscript, several Au NPs are arranged to resemble a line along the yellow dotted lines.
Figure S1. MQB-HVEM images acquired (a) before irradiation and after (b) 1, (c) 2, (d) 3, (e) 4, (f) 50, (g) 100, (h) 300 and (i) 600 irradiation pulses.
Figure S2. Comparison images of initial/final images comparing (a) 1 pulse/2 pulses, (b) 2 pulses/3 pulses, (c) 3 pulses/4 pulses, (d) 4 pulses/50 pulses, (e) 50 pulses/100 pulses, (f) 100 pulses/300 pulses, (g) 300 pulses/600 pulses. Movement and coalescence and growth are indicated.
pulses, (c) 3 pulses/4 pulses, (d) 4 pulses/50 pulses, (e) 50 pulses/100 pulses, (f) 100 pulses/300 pulses
and (g) 300 pulses/600 pulses. In the comparison images (a)-(g), the Au NPs appearing in the initial
image are colored red and those in the final image are blue.
S2. Fast Fourier transform (FFT) analysis of the Au NPs distribution after laser irradiation.

Figure S3 shows MQB-HVEM images of (a) after 1 irradiation pulse and (d) after 600 irradiation pulses, lower right inset of (a) and (d) the corresponding fast Fourier transform (FFT) patterns, respectively. Figure S3 (b) and (e) show the autocorrelation functional (ACF) image obtained by FFT patterns in Figure S3 (a) and (d), respectively. Figure S3(c) and (f) show the line profiles in the direction of red dotted line as shown in Figure S3 (b) and (e), respectively. After 600 irradiation pulses, bright pair dots are appeared in the ACF image (Figure S3 (e)) and the distance between the bright dots are about 275 nm in the line profiles image (Figure S3 (f)). These results indicate that the distribution of the Au NPs began to evolve in a line arrangement. Moreover, the direction of several Au NPs movement is toward the yellow dotted line as shown in Figure 2 and Figure S2.
Figure S3. MQB-HVEM images of (a) after 1 irradiation pulse and (d) after 600 irradiation pulses, lower right inset of (a) and (d) the corresponding fast Fourier transform (FFT) patterns, respectively, (b) and (e) the autocorrelation functional (ACF) image obtained by FFT patterns in (a) and (d), respectively.